

<b>Notice of References Cited</b>	Application/Control No. 10/706,993	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Scott B. Geyer	Art Unit 2829	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US- 5795797	08-1998	Chester et al.	—
*	B	US- 5518956	05-1996	LIU et al.	—
*	C	US- 5429994	07-1995	ISHIKAWA	—
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	K	US-			
	L	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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